

U.S. Department of Commerce, Patent and Trademark Office				Attorney Docket No.: 004-4911-1		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application No.: 09/940,242		
(Use several sheets if necessary)				Applicant(s): Michael L. Van De Vanter and Marat Boshernitsan		
				Filing Date: August 27, 2001		
				Group Art Unit: 2124 2124		
				Date Submitted: March 24, 2003		
U.S. Patent Documents						
*Examiner Initial		Document Number	Date	Name		
TF	AA	5,070,478	Dec. 3, 1991	Abbott		
	AB	5,079,700	Jan. 7, 1992	Kozoll et al.		
	AC	5,140,521	Aug. 18, 1992	Kozol et al.		
TF	AD	5,583,762	Dec. 10, 1996	Shafer		
	AE					
	AF					
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	AH					
	AI					
	AJ					
	AK					
Foreign Patent Documents						
					Translation	
		Document	Date	Country	Yes	No
	AL					
	AM					
	AN					
	AP					
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
	AR					
	AS					
	AT					
Examiner	[Signature]		Date Considered 5/31/04			
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				Group Art Unit: 222 Technology Center 2100			
				Date Submitted: October 11, 2001			
U.S. Patent Documents							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
TF	AA	5,737,608	Apr. 7, 1998	Van De Vanter	395	701	
	AB	5,748,975	May 5, 1998	Van De Vanter	395	793	
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	AD	5,802,262	Sep. 1, 1998	Van De Vanter	395	180	
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TF	AG	5,857,212	Jan. 5, 1999	Van De Vanter	707	519	
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Foreign Patent Documents							
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	Document	Date	Country	Class	Subclass	Yes	No
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TF	AR	Rolf Bahlke and Gregor Snelting, "The PSG System: From Formal Language Definitions to Interactive Programming Environments," <i>ACM Transactions on Programming Languages and Systems</i> Vol. 8, No. 4 (Oct. 1986), pp. 547-576.					
TF	AS	R. A. Balance, S. L. Graham and M. L. Van De Vanter, "The Pan Language-Based Editing System," <i>ACM Transactions on Software Engineering and Methodology</i> , Vol. 1, No. 1 (Jan. 1992), pp. 95-127.					
TF	AT	B. Borras et al., "CENTAUR: the system," <i>Proceedings ACM SIGSOFT '88: Third Symposium on Software Development Environment</i> (Nov. 1988), pp. 14-24.					
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		Date Submitted: October 4, 2001
NON PATENT LITERATURE DOCUMENTS		
*Examiner Initial	No.	(Including name of author in capital letters, title of article, title of item, date, pertinent pages, volume-issue number(s), publisher, city and/or country where published.)
TF	AA	V. Donzeau-Gouge et al., "Programming Environments Based on Structured Editors: The MENTOR Experience," <i>Interactive Programming Environments</i> , David R. Barstow et al., editors, McGraw-Hill, New York, NY (1984), pp. 128-140.
	AB	Bernard Lang, "On the Usefulness of Syntax Directed Editors," <i>Advanced Programming Environments, Lecture Notes in Computer Science</i> , vol. 244, Reidar Conradi et al, editors, Springer Verlag, Berlin (1986), pp. 47-51.
	AC	S. Letovsky and E. Soloway, "Delocalized Plans and Program Comprehension," <i>IEEE Software EE</i> (May 1986), pp. 41-49.
	AD	Lisa Rubin Neal, "Cognition-Sensitive Design and User Modeling for Syntax-Directed Editors," <i>Proceedings SIG-CHI Conference on Human Factors in Computing Systems</i> , Toronto, Canada (April 1987), pp. 99-102.
	AE	David Notkin, "The GANDALF Project," <i>Journal of Systems and Software</i> Vol. 5, No. 2 (May 1985), pp. 91-105.
	AF	T. Reps and T. Teitelbaum, <i>The Synthesizer Generator Reference Manual, Texts and Monographs in Computer Science</i> , 3rd Ed., Springer-Verlag, NY, 1989, 180 pages.
	AG	E. Soloway and K. Ehrlich, "Empirical Studies of Programming Knowledge," <i>IEEE Transactions on Software Engineering</i> , Vol. SE-10, No. 5 (Sept. 1984), pp. 595-609.
	AH	Richard M. Stallman, "EMACS: The Extensible, Customizable, Self-Documenting Display Editor," <i>Proceedings of the ACM-SIGPLAN SIGOA Symposium on Text Manipulation, SIGPLAN Notices</i> , Vol. 16, No. 6 (June 8-10, 1981), pp. 147-156.
	AI	T. Teitelbaum and T. Reps, "The Cornell Program Synthesizer: A Syntax-Directed Programming Environment," <i>Communications of the ACM</i> , Vol. 24, No. 9 (Sept. 1981), pp. 563-573.
	AJ	M. Van De Vanter et al., "Coherent User Interfaces for Language-Based Editing Systems," <i>International Journal of Man-Machine Studies</i> , Vol. 37, No. 4 (1992), pp. 431-466.
TF	AK	Michael L. Van De Vanter, "Practical Language-Based Editing for Software Engineers," <i>Software Engineering and Human-Computer Interaction: ICSE '94 Workshop on SE-HCI: Joint Research Issues, Sorrento, Italy, May 1994 Proceedings</i> , Lecture Notes in Computer Science, Vol. 896, Richard N. Taylor and Joelle Coutaz, editors, Springer Verlag, Berlin (1995), pp. 251-267.
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